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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10032287	12/21/2001	349	113	2871	Di Grazio

**APPLICANTS: Tsuyuki Tadashi; Matsuo Mutsumi; Tanaka Chihiro;

**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:

JAPAN 2000-392828 12/25/2000

JAPAN 2001-347606 11/13/2001

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RESCIND ☐

Foreign priority claimed ☐ yes ☐ no

35 USC 119 conditions met ☐ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

9319S-000308

TITLE : Substrate for a liquid crystal device, method of manufacturing a substrate for a liquid crystal device, a liquid crystal device, a method of manufacturing a liquid crystal device, and an electro

U.S. DEPT. OF COMM. PAT. & TM. PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
Assistant Examiner		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drawn	Figs. Drawn
Primary Examiner		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Applicant's Examiner	
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